

Notice of References Cited

Application/Control No.

10/564,837

Applicant(s)/Patent Under

Reexamination

HONGO ET AL.

Examiner

Chun-Cheng Wang

Art Unit

1796

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U.S. PATENT DOCUMENTS

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
A	US-			
B	US-			
C	US-			
D	US-			
E	US-			
F	US-			
G	US-			
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

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N	JP2002-180110	06-2002	JP	Katsuhiro et al.	B22F 9/00, 9/24; B01
O	JP 2002-060805	02-2002	JP	Naoki et al.	B22F 9/00; B01J 13/0
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NON-PATENT DOCUMENTS

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
U	Meltzer et al. "Filtration in the Pharmaceutical Industry", Marcel Dekker, New York, 1998, page 548-559 and 636-637
V	Tateishi et al. "Scrapie Removal using Planova Removal Filters", Biological (2001) 29, page 17-25
W	
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.